

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:

Toshikazu ISHIKAWA et al.

Appln. No.:

Filed: HEREWITH

For: SEMICONDUCTOR DEVICE

* * *

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

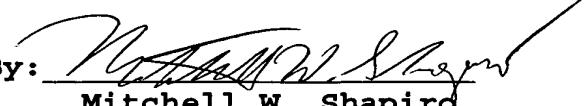
Pursuant to 37 C.F.R. § 1.56, and without any assertion as to materiality or prior art effect, the document listed on the attached Form PTO-1449 is hereby cited.

The document on the attached List was cited in the specification, on page 2, and its relevance is indicated therein.

Respectfully submitted,

MWS:lat

Miles & Stockbridge P.C.
1751 Pinnacle Drive
Suite 500
McLean, Virginia 22102-3833
(703) 903-9000

By: 
Mitchell W. Shapiro
Reg. No. 31,568

November 3, 2003

FORM PTO-1449		Atty. Docket No. XA-9960	Appln. No.
LIST OF DOCUMENTS CITED BY APPLICANT			

		Applicant Toshikazu ISHIKAWA et al.	
		Filing Date HEREWITH	Group

U.S. PATENT DOCUMENTS

Examiner Initial		Document Number	Date	Name	Class	Sub-class	Filing Date
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						

FOREIGN PATENT DOCUMENTS

Examiner Initial		Document Number	Date	Country	Class	Sub-class	Translation
	AJ	WO 02/103793	12/27/02	PCT			Abstract
	AK						
	AL						
	AM						
	AN						
	AO						

OTHER (including author, title, date, pertinent pages, etc.)

AP	
AQ	
AR	

Examiner	Date Considered
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.	